



## Press release

Lund, Sweden

May 04, 2021

### **Epiluvac appoints Dr Michael MacMillan as Vice President, Sales and Marketing**

Epiluvac AB, the Swedish manufacturer of CVD equipment for wide-bandgap semiconductors, today announced that Dr Michael MacMillan has joined the company as Vice President of Sales and Marketing. Dr MacMillan will be responsible for Epiluvac's global sales and marketing, and will be based at the company's new office in Orange County, CA, USA.

Bo Hammarlund, Board Director, Business Development says - "This is an important milestone for Epiluvac. We see a growing demand for the next generation CVD equipment, not only for Silicon Carbide (SiC) but also for Gallium Nitride (GaN). Mike's expertise in SiC epitaxy, together with his long experience from both research and manufacturing companies, will certainly bring exciting benefits to our products and also our customers."

Dr MacMillan was recently Chief Epitaxial Scientist at SemiQ (formerly Global Power Technologies Group), Lake Forest, CA, and his career spans from early SiC research at Linköping University, Sweden in the 1990's to many years as leader and SiC scientist in major US companies like Northrop Grumman and Dow Corning. Dr MacMillan holds a PhD in Physics from University of Pittsburgh.

"This is a great opportunity and privilege to be part of this highly skilled team with their new, exciting CVD platform for wide bandgap semiconductors," says Dr MacMillan.



*Dr Michael MacMillan*

### **About Epiluvac**

Epiluvac AB, headquartered in Lund, Sweden, makes manufacturing equipment for wide bandgap semiconductor materials, primarily Silicon Carbide (SiC) and Gallium Nitride (GaN).



Epiluvac has recently introduced a new unique product generation, primarily intended for SiC and GaN epitaxy. These materials are now increasingly applied as a better alternative to silicon in several applications such as electric vehicles, solar power and trains where energy efficiency and size requirements are challenging. The new “WBG-Multi-Reactor-CVD” systems are based on so called hot-wall CVD and single-wafer processing of up to 200 mm (8”) wafers with option to connect multiple chambers and wafer handling robots together in a cluster tool configuration to meet each customer’s requirement for higher output, flexibility or stepwise wafer processing through multiple chambers. Epiluvac’s products are sold worldwide either directly or through local partners.

For more information about Epiluvac’s range of CVD equipment for epitaxy and wide bandgap semiconductors like SiC and GaN, visit [www.epiluvac.com](http://www.epiluvac.com) or contact [sales@epiluvac.com](mailto:sales@epiluvac.com).

Download high resolution pictures at: [www.epiluvac.com/press/](http://www.epiluvac.com/press/)